

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Shoji Miyazaki et al.
Appl. No. : 10/809,217
Filed : March 25, 2004
For : BIOSENSOR, THIN FILM ELECTRODE FORMING METHOD,
QUANTIFICATION APPARATUS, AND QUANTIFICATION
METHOD
Customer No. : 1912
Art Unit : 1795
Confirmation No.: 6571
Examiner : Alexander Stephan Noguerola

**COMMUNICATION AND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Notice of Allowance was issued on July 26, 2010 in connection with the above-identified application. The Fees Transmittal Form PTOL-85 and fee payment are due October 26, 2010 and have not been submitted. Accordingly, this Request for Continued Examination (RCE) and Supplemental Information Disclosure Statement (SIDS) are being timely filed. Authorization is hereby given to charge the \$810.00 fee for a Request for Continued Examination to Deposit Account No. 01-1785.

Supplemental Information Disclosure Statement

In accordance with the duty of disclosure under 37 C.F.R. §1.56, applicants would like to direct the Examiner's attention to the references that are listed on the attached form PTO/SB/08A (4 pages). A copy of the foreign patent document and non patent literature documents are also attached. Most of these references were cited in a European Search Report issued on June 29, 2010 by the European Patent Office in connection with patent family member European Application No. 09177290.5. A copy of the Search Report is attached hereto.

Authorization is hereby given to charge the \$810.00 fee for a Request for Continued Examination and any required additional fee to Deposit Account No. 01-1785.

Respectfully submitted,

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Dated: September 16, 2010
New York, New York

By /Alan D. Miller/
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